



PATENT APPLICATION

THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date June 18, 2008

In re the Application of

Hideki SATO

Group Art Unit: 1792

Application No.: 10/594,458

Examiner: L. UINH

Filed: September 26, 2006

Docket No.: 129546

For: METHOD FOR EVALUATING CRYSTAL DEFECTS OF SILICON WAFER

**LARGE ENTITY PETITION FOR 1<sup>st</sup> - 3<sup>rd</sup> EXTENSION  
OF TIME UNDER 37 C.F.R. §1.136(a) AND  
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired May 19, 2008, an extension of time for a period of 1 month is hereby requested. Attached hereto is our Check No. 206815 in the amount of \$120 in payment for:

X Extension fee for response within first month pursuant to §1.136(a) (\$120.00)  
\_\_\_\_\_ Extension fee for response within second month pursuant to §1.136(a) (\$460.00)  
\_\_\_\_\_ Extension fee for response within third or subsequent month pursuant to §1.136(a) (\$1050.00)

The Commissioner is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461.

Respectfully submitted,

William P. Berridge  
Registration No. 30,024

Nicolas A. Brentlinger

Registration No. 62,211

06/19/2008 JADD01 00000021 10594458

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WPB:NAB/mcp

OLIFF & BERRIDGE, PLC  
P.O. Box 320850  
Alexandria, Virginia 22320-4850  
Telephone: (703) 836-6400

DEPOSIT ACCOUNT USE  
AUTHORIZATION

Please grant any extension  
necessary for entry;

Charge any fee due to our  
Deposit Account No. 15-0461



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**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the February 19, 2008 Office Action, the statutory period for reply being extended by the attached Petition for Extension of Time, please consider the following:

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**